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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Satoshi KAMIYAMA et al.**

Group Art Unit: **1722**

Application Number: **10/500,002**

Examiner: **Matthew J. Song**

Filed: **November 16, 2004**

Confirmation Number: **2766**

For: **GROUP III NITRIDE SEMICONDUCTOR SUBSTRATE AND ITS
MANUFACTURING METHOD**

Attorney Docket Number: **042398**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 25, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 29, 2006 for 1 month from March 29, 2007 to April 29, 2007.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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